

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 09/449,025  
Priority Filing Date ..... November 24, 1999  
Inventor..... Shozo Nagano et al.  
Assignee ..... Honeywell International, Inc.  
Priority Group Art Unit ..... 1775  
Examiner ..... Unknown  
Attorney's Docket No. ..... 30-5000-(4015)-Div2  
Title: Physical Vapor Deposition Targets

9/23/01  
C.F.  
7/23/01

PRELIMINARY AMENDMENT

To: Box Patent Application  
Assistant Commissioner for Patents  
Washington, D.C. 20231

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)  
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Sir:

Please enter the following amendments prior to examining the above-identified application.

AMENDMENTS

In the Title

Please replace the title with the following: --PHYSICAL VAPOR  
DEPOSITION TARGETS.--

In The Specification

At page 1 before the "Technical Field" section, please insert the following:

RELATED PATENT DATA

This patent resulted from a divisional application of U.S. Patent Application Serial No. 09/449,025, filed November 24, 1999, entitled "Physical